## PAGE 3/9 \* RCVD AT 12/16/2003 7:35:21 PM [Eastern Standard Time] \* SVR:USPTO-EFXRF-2/1 \* DNIS:7468433 \* CSID:202 293 7860 \* DURATION (mm-ss)-10:48

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			<u> FAX</u>
Date	August 18, 2003		
То	Examiner NGUYEN, Lam S.		
Of	PTO Group Art Unit 2853		
Fax	703-872-9306		
From	Stan Torgovitsky		
Subject	Request for Reconsideration		
Our Ref	Q65741	Appln No	09/921,683
Conf No	8175	Inventors	Junhua CHANG
Pages	6 (including cover sheet)		

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This fax filing includes:

- 1. This cover sheet
- 2. Request for Reconsideration

## CERTIFICATION OF FACSIMILE TRANSMISSION

Sir:

I hereby certify that the above identified correspondence is being facsimile transmitted to Examiner NGUYEN, Lam S. at the Patent and Trademark Office on August 18, 2003 at 703-872-9306.

Respectfully submitted,

Stan Torgevitsky Reg. No. 43,958

DEC-19-5002 12:20 20CHBNE WION

REQUEST FOR RECONSIDERATION **EXPEDITED PROCEDURE GROUP 2853 PATENT APPLICATION** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q65741

Junhua CHANG

Group Art Unit: 2853

Appln. No.: 09/921,683

Confirmation No.: 8175

Examiner: NGUYEN, Lam

TECHNOLOGY CENTER 2800

Filed: August 06, 2001

LIQUID JETTING APPARATUS AND METHOD OF DRIVING THE SAME For:

## REQUEST FOR RECONSIDERATION

AND

SUMMARY OF SUBSTANCE OF EXAMINER INTERVIEW

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 AUG 1 8 2003

Sir:

In response to the Office Action dated March 10, 2003, in view of the Advisory Action dated June 27, 2003, and further in view of the Examiner Interview held on August 4, 2003, please consider the following: